

## Indian Institute of Technology Bombay, Powai, Mumbai-400076 Department of Metallurgical Engineering & Materials Science

Registration form for using NanoIndenter facility(nanoindenter@iitb.ac.in)

External Registration No:	Date:
1) Name of the User	:
2) Name of the Dept/Div/Sec	:
3) Email and Tel No	:
4) Number of samples (Maximur	m 4):
5) Specifications of sample	
Size of sample (≤ 1cm)	:
Polishing	:
	i) Maximum load ii) Location ofiii) Loading/Unloading rate
ii) Range of frequency (<300 Hz) Specify how many tests per sample	: i)Applied load )
	ERIAL IS NOT POISONOUS OR TOXIC IN ANY WAY
	the publications appropriate acknowledgment of usage of IIT's nentioned. The details can be forwarded to nanoindenter@iitb.ac.in
Signature of the User	<b>:</b>
as possible and polished to mir polishing for conducting samples not be epoxy mounted when you	ntation are very sensitive to surface preparation. The sample should be as flat ror finish. It is strongly recommended to finish polishing with :- Electro ,Colloidal Silica polishing for non-conducting samples.2)The sample should give it for nanoindentation.
Sample Received Date:	
Period of Analysis:	Results Sent Date:
Experiment completed date:	Signature of Operator: